



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Atsushi YAMAGUCHI et al.

Group Art Unit: 2851

Application No.: 10/022,228

Examiner: H. Nguyen

Filed: December 20, 2001

Docket No.: 111476

For: EXPOSURE APPARATUS AND EXPOSURE METHOD

AMENDMENT FILED WITH
REQUEST FOR CONTINUED EXAMINATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to further examination in response to the Request for Continued Examination
filed herewith, please consider the following:

Amendment to the Claims are reflected in the listing of claims; and

Remarks.

RECEIVED
JUL -8 2003
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